Notice of References Cited Application/Control No. 10/642,533 Examiner Paul D Kim Applicant(s)/Patent Under Reexamination SATO, KIYOSHI Page 1 of 1

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|---------------|----------------|
| | Α | US-6,226,149 | 05-2001 | Dill et al. | 360/126 |
| | В | US-6,113,464 | 09-2000 | Ohmori et al. | 451/41 |
| | С | US-5,952,041 | 09-1999 | Sato et al. | 427/129 |
| | D | US- | | | |
| | Е | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | Н | US- | | · | |
| | 1 | US- | | | - |
| | J | US- | | | |
| | К | US- | | | |
| | L | US- | | | |
| | М | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------------------|----------------|
| | N | JP 06187613 A | 07-1994 | Japań | TAKEDA, KAZUHIKO | G11B 05/31 |
| | 0 | | | | | |
| | Ք | | | | | |
| | ø | | | | | |
| | R | | | | | |
| | S | | | | | |
| | Т | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|--|
| | υ | "Floating thin film head fabricated by ion etching method"; Nakanishi, T.; Kogure, K.; Toshima, T.; Yanagisawa, K.; Magnetics, IEEE Transactions on , Volume: 16 , Issue: 5 , Sep 1980; Pages:785 - 787. |
| | ٧ | |
| | W | |
| | х | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.